

S/N 10/823,314

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Neo C. Peng et al.

Examiner: Samuel Heinrich

Serial No.: 10/823,314

Group Art Unit: 1725

Filed: April 13, 2004

Docket No: 303.772US2

Title: WAFER DICING DEVICE AND METHOD

PETITION FOR A ONE-MONTH EXTENSION OF TIME

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

In accordance with the provision of 37 CFR § 1.136(a), it is respectfully requested that a one-month extension of time be granted in which to respond to the Office Action mailed January 5, 2006, said period of response being extended from April 5, 2006 to May 5, 2006.

Please charge Deposit Account 19-0743 in the amount of \$120.00 to cover the required extension fee. Please charge any additional fees or credit overpayment to deposit Account No. 19-0743.

Respectfully Submitted

NEO C. PENG ET AL.

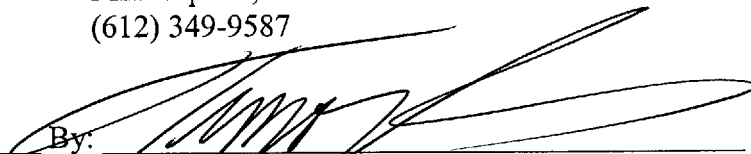
By their Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.
P.O. Box 2938
Minneapolis, MN 55402
(612) 349-9587

Date:

19 April '06

By:



Timothy B. Clise
Reg. No: 40,957

CERTIFICATE UNDER 37 CFR § 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 19 day of April 2006.

Name: KATE GANNON

Signature: Kate Gannon